



THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

NELSON *et al.*

Appl. No. 09/841,187

Filed: April 25, 2001

For: Method and System for Improving
Focus Accuracy in a Lithography
System

Confirmation No.: 3650

Art Unit: 2851

Examiner: Esplin, D.

Atty. Docket: 1857.0350000

Amendment And Reply Under 37 C.F.R. § 1.111

Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450

Sir:

In reply to the Office Action dated June 19, 2003, Applicants submit the following
Amendment and Remarks. This Amendment is provided in the following format:

- (A) Each section begins on a separate sheet;
- (B) Starting on a separate sheet, amendments to the specification by
presenting replacement paragraphs marked up to show changes made;
- (C) Starting on a separate sheet, a complete listing of all of the claims:
 - in ascending order;
 - with status identifiers; and
 - with markings in the currently amended claims;
- (D) Starting on a separate sheet, the Remarks.

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A petition for a one-month extension of time is filed herewith, along with the
appropriate fee. It is not believed that any further extensions of time, or fees for net addition
of claims, are required. If additional extensions of time are necessary to prevent

abandonment of this application, then such extensions of time are hereby petitioned under 37 C.F.R. § 1.136(a), and any fees required therefor (including fees for net addition of claims) are hereby authorized to be charged to our Deposit Account No. 19-0036.